

200/576476

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  
[AP20 Rec'd PCT/PTO 20 APR 2006]

In re application of :  
Seiji AKITA et al. : **Mail Stop: PCT**  
Serial No. NEW : Attorney Docket No. 2006\_0598A  
Filed April 20, 2006 :

NANOSIZE HEATER-MOUNTED  
NOZZLE AND METHOD FOR  
MANUFACTURING SAME AND  
METHOD FOR FORMING MICRO  
THIN FILM

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975

[Corresponding to PCT/JP2004/015598  
Filed October 21, 2004]

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**PRELIMINARY AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Prior to examination of the above-referenced U.S. patent application please  
amend the application as follows: